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From: Andrew J. Telesz, Jr.

Subject: Serial No.: 10/627,734
Our Ref. No.: OKI.557

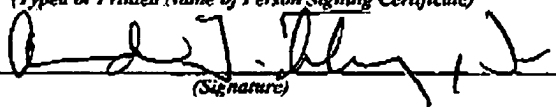
No. of Pages (including cover): 24

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Comments:

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CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)			Docket No.
Applicant(s): Takeshi Morita			OKI.557
Application No. 10/627,734	Filing Date July 28, 2003	Examiner C. Everhart	Group Art Unit 2825
Invention: METHOD FOR ESTIMATING REMAINING FILM THICKNESS DISTRIBUTION, METHOD FOR DESIGNING PATTERNING MASK USING THE METHOD FOR ESTIMATING REMAINING FILM THICKNESS DISTRIBUTION, AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICES BY USING...			
<p>I hereby certify that this <u>Combined Amendment and Petition for Extension of Time Under 37 C.F.R. 1.136(a)</u> (Identify type of correspondence)</p> <p>is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>703-872-9306</u>)</p> <p>on <u>November 9, 2004</u> (Date)</p> <p style="text-align: right;"><u>Andrew J. Telesz, Jr.</u> (Typed or Printed Name of Person Signing Certificate)</p> <p style="text-align: right;"> (Signature)</p> <p style="text-align: center;">Note: Each paper must have its own certificate of mailing.</p>			

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Serial No. 10/627,734

OKI.557

Amendment dated November 9, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Takeshi Morita

Group Art Unit: 2825

Serial No.: 10/627,734

Examiner: C. Everhart

Filed: July 28, 2003

Confirm. No.: 3806

For: METHOD FOR ESTIMATING REMAINING FILM THICKNESS DISTRIBUTION,
METHOD FOR DESIGNING PATTERNING MASK USING THE METHOD FOR
ESTIMATING REMAINING FILM THICKNESS DISTRIBUTION, AND METHOD
FOR MANUFACTURING SEMICONDUCTOR DEVICES BY USING
PATTERNING MASK DESIGNED BY USING THE METHOD FOR ESTIMATING
REMAINING FILM THICKNESS DISTRIBUTION

AMENDMENT

U.S. Patent and Trademark Office
220 20th Street S.
Customer Window, **Mail Stop Amendment**
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Date: November 9, 2004

Sir:

In response to the Office Action dated June 9, 2004, the period for response having been extended two (2) months to November 9, 2004, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

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OKI.557

Amendment dated November 9, 2004

Remarks/Arguments begin on page 8 of this paper.